

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Brask

Examiner: Kathleen Duda

Application No.: 10/658,225

Art Unit: 1756

Filed: September 8, 2003

For: METHODS AND COMPOSITIONS  
FOR SELECTIVELY ETCHING METAL  
FILMS AND STRUCTURES

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Dear Examiner:

This is in response to the Office Action mailed January 26, 2007. Applicants respectfully request the Examiner to enter this Amendment and consider the following remarks.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** begin on page 3 of this paper.

**Remarks** begin on page 7 of this paper.

**Filed via EFS Web**